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Approved for use through 10/31/02. OMB 0651-0031

				Application Number	10/058,263			
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Application Number

AFE &KAN:	SIVII I 1 A I						
			Filing Date	January	25, 2002		
R 2 700k F	DRM		First Named Inventor	Milad F.	Tabet		
			Group Art Unit	2877			
(to be seed for all corre	espondence after initial	filing)	Examiner Name	Unknown			
Total Number Of Pages In T	his Submission 4	+ 1 ref.	Attorney Docket No.	NAN028 US			
ENCLOSURES (check all that apply)							
Fee Transmittal Fo	Fee Transmittal Form				After Allowance Communication to Group		
Fee Attache	ed	Dra	wing(s)		Appeal Communication to Board of Appeals and Interferences		
Amendment / Repl	у	Lice	ensing-related Papers	Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)			
After Final		Pet	ition		Proprietary Information		
Affidavits/de	eclarations		ition to Convert to a visional Application		Status Letter		
Extension of Time	Extension of Time Request Po				Other Enclosure(s) (please identify below):		
Express Abandonment Request			minal Disclaimer quest for Refund		*Return Receipt Postcard Transmittal Form (1 page) *PTO Form 1449 (1 page) Copy of one Cited Reference		
Information Disclosure Statement (2 pages)			, Number of CD(s)				
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Response to Missir Incomplete Applica	Response to Missing Parts/ Incomplete Application						
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or Michael J. Halbert (Reg. Silicon Valley Patent Gro			•				
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Michael I Halb	ert / W		<u>N</u>	<u> 1arch 17, 2</u>	:004		



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Milad F. Tabet

Assignee:

Nanometrics Incorporated

Title:

Method of Measuring Small Pads on a Substrate

Serial No.:

10/058,263

Filing Date:

January 25, 2002

Examiner:

Unknown

Group Art Unit:

2877

Docket No.:

NAN028 US

Confirmation No:

4087

Santa Clara, California March 17, 2004

COMMISSIONER FOR PATENTS P.O. BOX 1450 **ALEXANDRIA, VA 22313-1450**

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the document listed on the accompanying Form PTO-1449. A copy of this document is also submitted herewith. The Examiner is requested to make this document of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not

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exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

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Michael J. Halbert

Respectfully submitted,

Michael J. Halbert Attorney for Applicants

Reg. No. 40,633

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U.S. Department of Commerce, Patent and Trademark Office	Application No.:	10/058,263	
IP E -Cig	Filing Date:	January 25, 2002	
	First Named Inventor:	Milad F. Tabet	
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(Use several sheets if necessary)	Confirmation No.:	4087	
	Attorney Docket No.:	NAN028 US	

			U.S.	Patent Documents				
*Examiner Intials	1.	Document Number 6,707,056 B2	Date 3-16-04	Name Fanton et al.	Class 250	Subclass 559.44	Filing Appr	Date if
	1.	0,707,030 B2	3-10-04	Famon et al.	230	339.44		
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